

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: MARUTA, Yuki et al

Serial Number: 10/708,587

Filed: March 12, 2004



For. **METHOD AND DEVICE FOR CUTTING WIRE FORMED ON SEMICONDUCTOR SUBSTRATE**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 22, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

Reference is discussed at paragraph [0004] of the specification.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,
HANSON & BROOKS, LLP

William L. Brooks

William L. Brooks
Attorney for Applicant
Reg. No. 34,129

WLB/mla
Atty. Docket No. 040103
Suite 1000
1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



23850

PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (1)



INFORMATION DISCLOSURE STATEMENT PTO-1449	Patent No. 040103	Serial No. 10/708,587
	Applicant(s): MARUTA, Yukio, et al.	
	Filing Date: March 12, 2004	Group Art Unit: Unassigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____	AE		
_____	AF		
_____	AG		
_____	AH		
_____	AI		

OTHER DOCUMENTS

_____	AJ	"Achieving Quick Design Debugging With Circuit Correction Function Using Focused Ion Beam Technique"; IBM, June 23, 1999, http://www-6.ibm.com/jp/chips/v5_1/mn51011.html .
_____	AK	
Examiner		Date Considered